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**Suzuki et al.**

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(54) **LINER FOR PLASMA PROCESSING APPARATUS**

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See application file for complete search history.

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(57) **CLAIM**

The ornamental design for a liner for plasma processing apparatus, as shown and described.

**DESCRIPTION**

FIG. 1 is a front view of a liner for plasma processing apparatus showing our new design;  
FIG. 2 is a top plan view thereof;  
FIG. 3 is a bottom plan view thereof;  
FIG. 4 is a right side view thereof;  
FIG. 5 is a sectional view taken along line 5-5 of FIG. 2 thereof; and,  
FIG. 6 is a perspective view thereof.

**1 Claim, 3 Drawing Sheets**

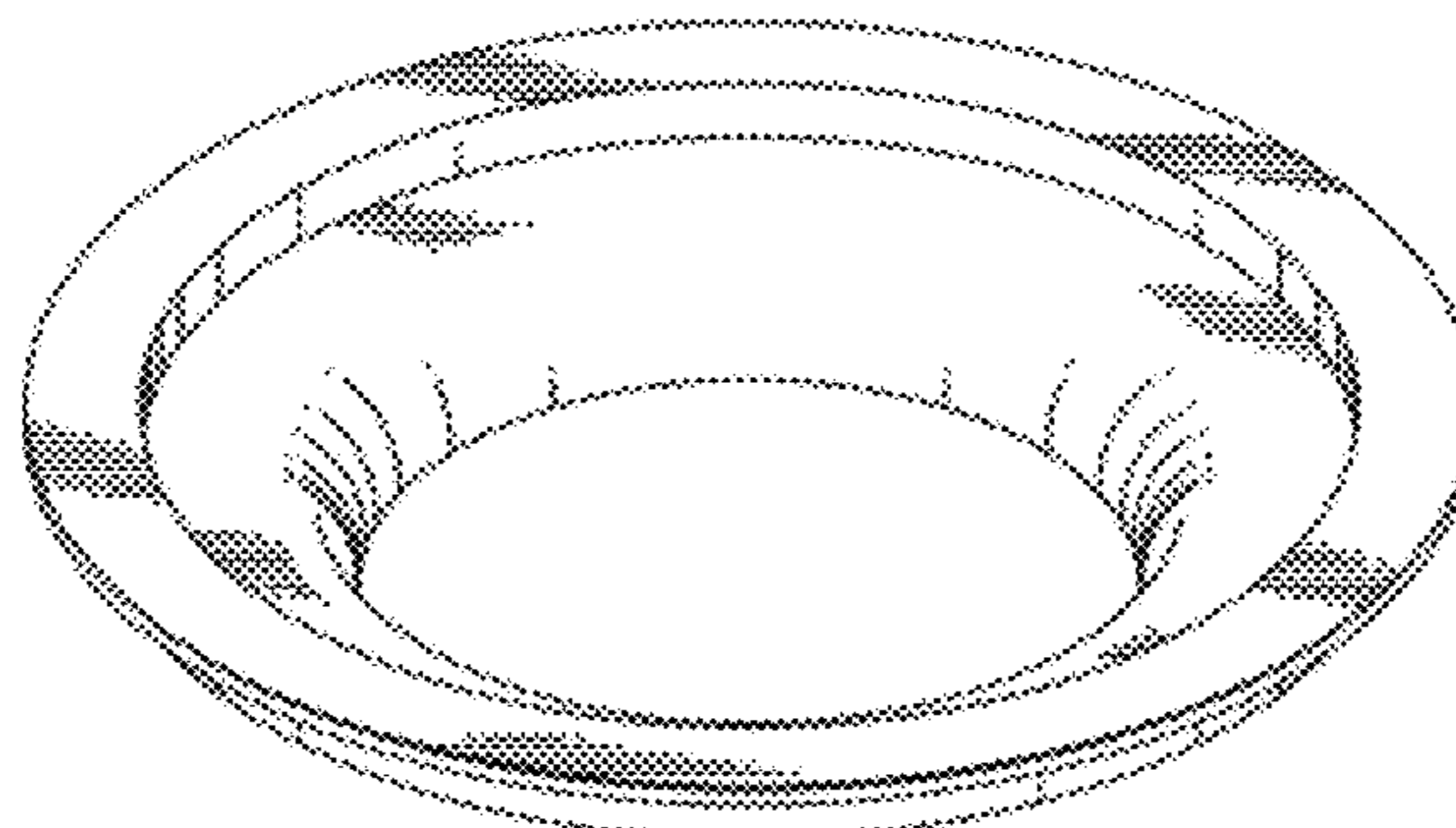


FIG. 1

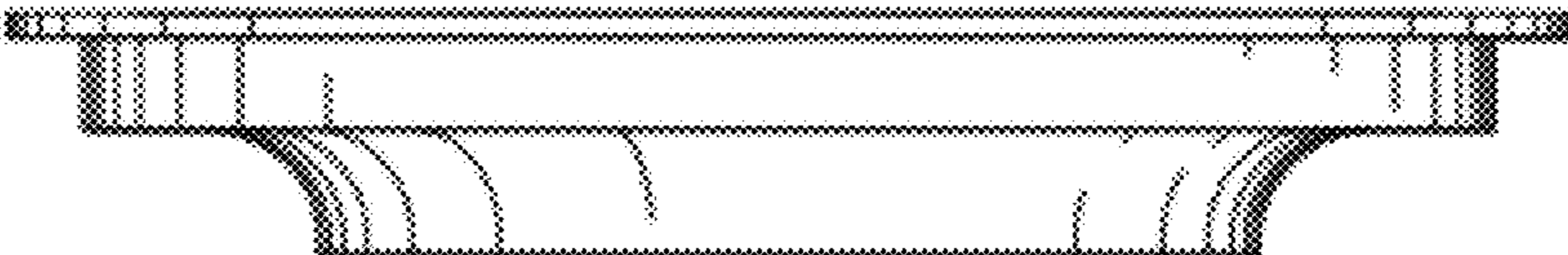


FIG. 2

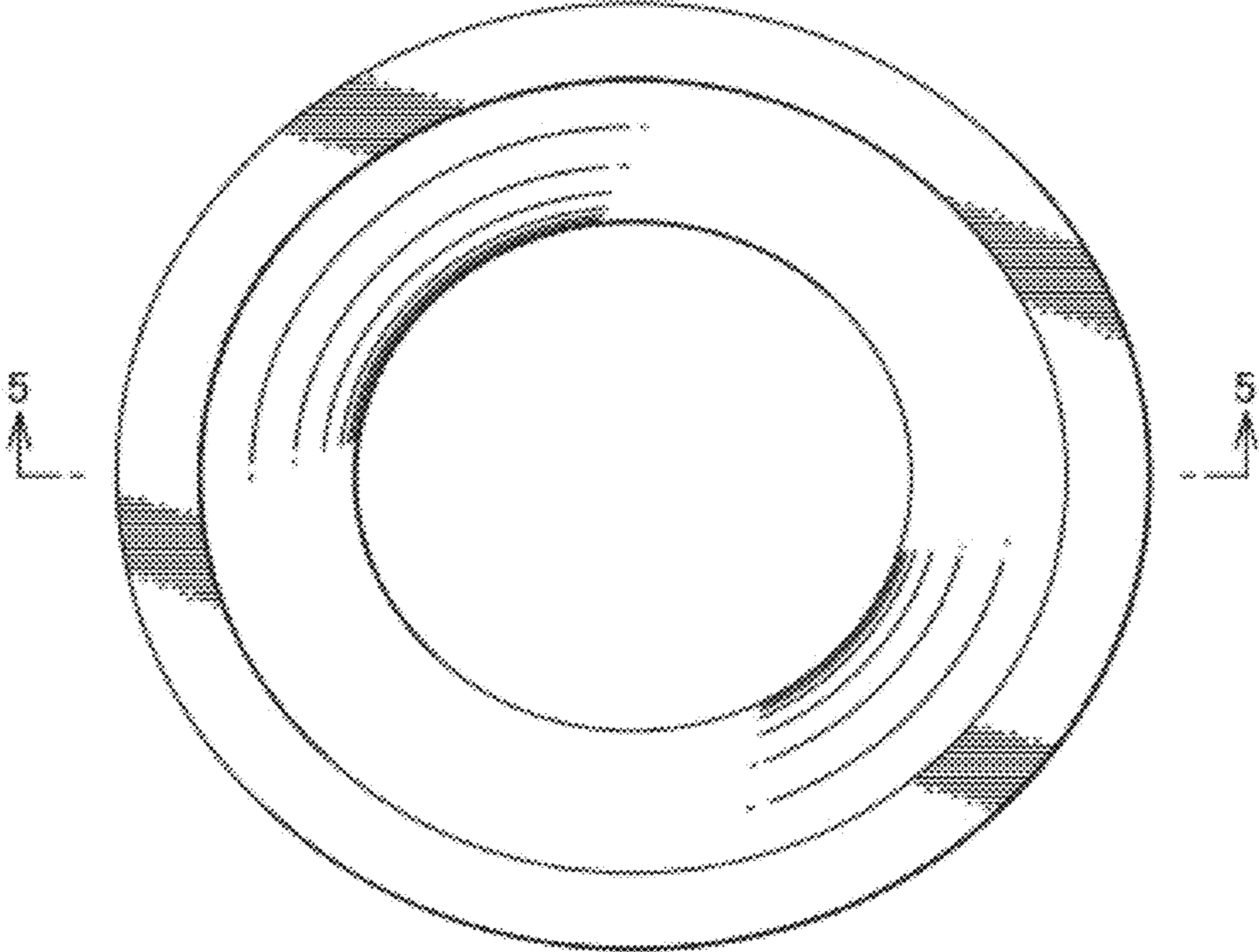


FIG.3

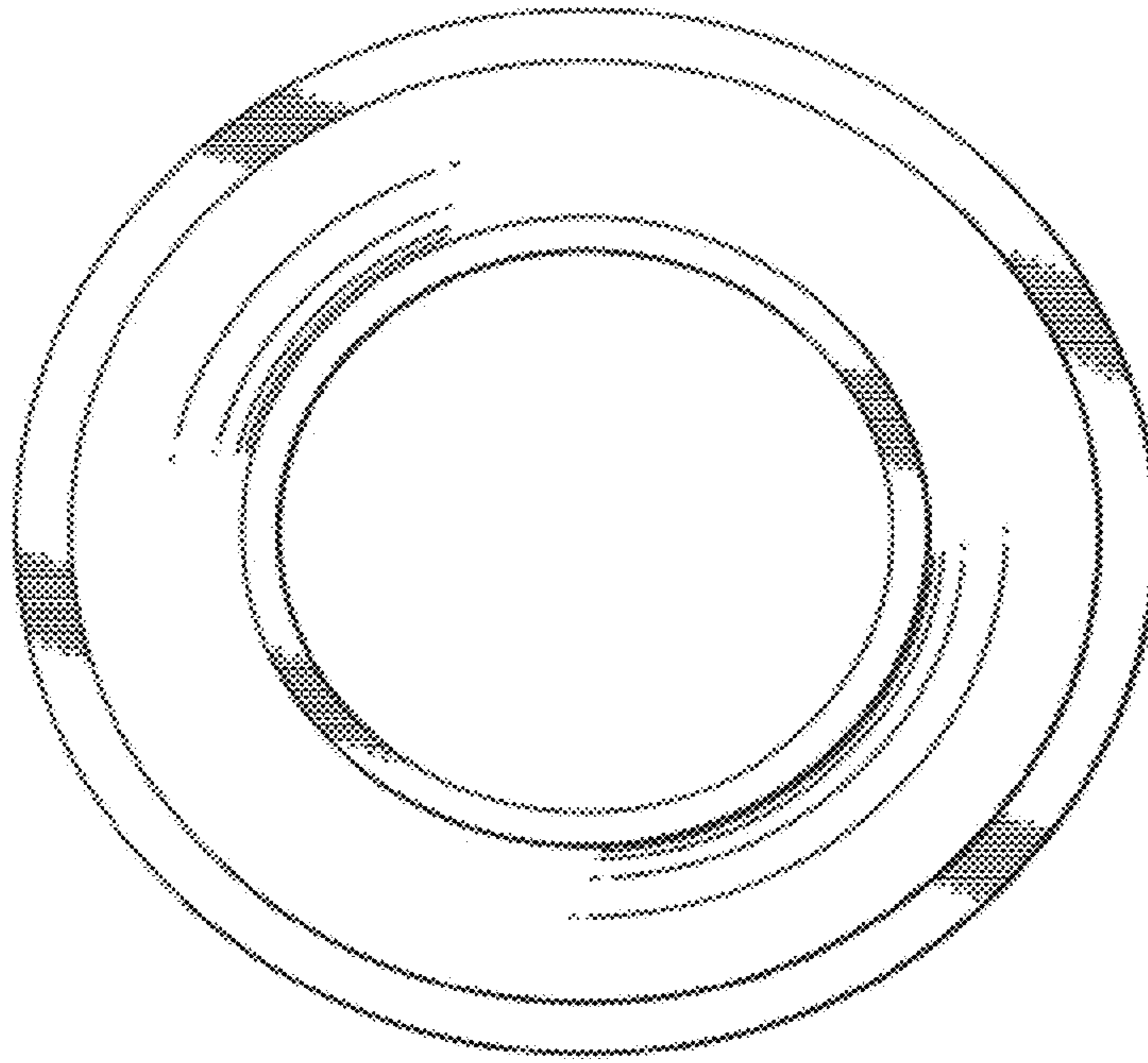


FIG.4

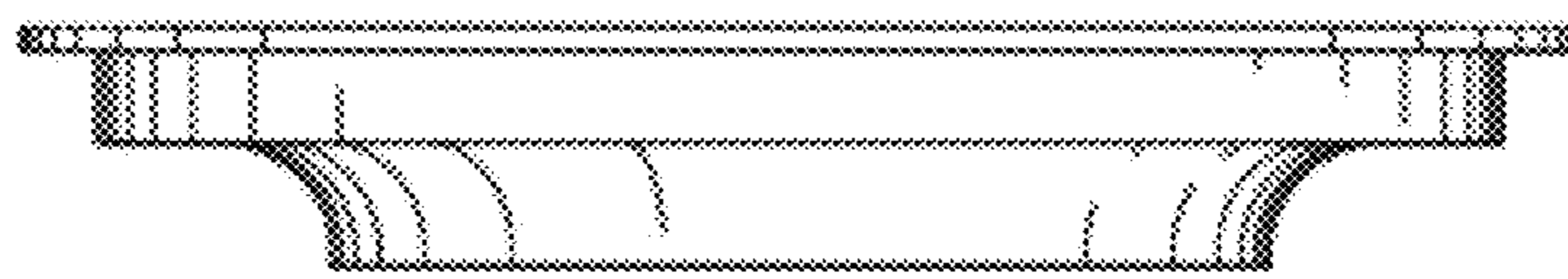


FIG.5

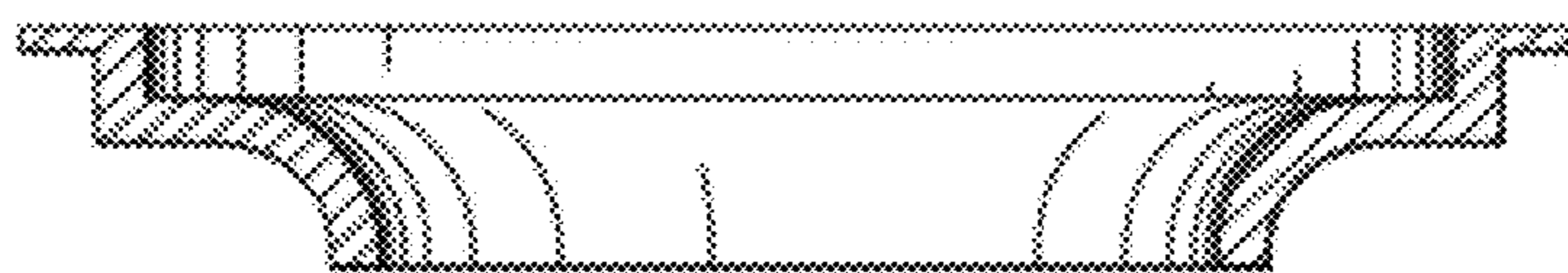


FIG.6

